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2823

PATENT
97-CT-174

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
RAFFAELE ZAMBRANO)	Group Art Unit: 2823
Serial No.: 09/191,743)	
Confirmation No.: 8970)	Examiner: M. Estrada
Filed: November 13, 1998)	
For: IN-SITU DEPOSITION AND)	
DOPING PROCESS FOR POLY-)	
CRYSTALLINE SILICON LAYERS)	
AND THE RESULTING DEVICE)	
_____)	

CORRECTED AMENDMENT SECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Notice of Non-Compliant Amendment dated February 25, 2004, in connection with the above-identified application, please enter and consider the following corrected section of the Amendment filed February 2, 2004.

I hereby certify that this correspondence is
being deposited with the United States Postal
Service with sufficient postage as first class
mail in an envelope addressed to:
Commissioner for Patents, P.O. Box 1450,

Alexandria, VA 22313-1450, on 3/25/04
Date of Deposit

Stephen Bongini
Applicant, Assignee, or Representative

[Signature] 3/25/04
Signature Dated